

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Masahide KAWARAYA, et al.**Serial Number: **Not Yet Assigned**  
(§371 of International Application PCT/JP03/13019)Filed: **April 6, 2005**For: **PROCESS FOR FORMING SEMICONDUCTOR FILM AND USE OF  
SEMICONDUCTOR FILM****INFORMATION DISCLOSURE STATEMENT**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

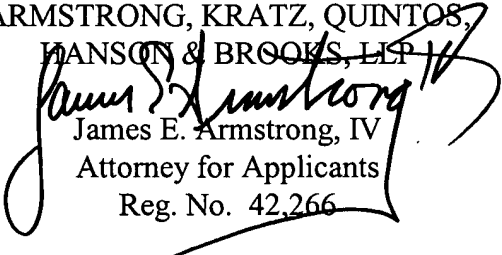
April 6, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and  
Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed  
international search report.

In the event there are any fees due in connection with the filing of this paper, please  
charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Atty. Docket No. <b>050179</b>	Serial No. <b>New Application</b>
	Applicant(s): <b>Masahide KAWARAYA, et al.</b>	
	Filing Date: <b>April 6, 2005</b>	Group Art Unit: <b>Not Yet Assigned</b>

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

**FOREIGN PATENT DOCUMENTS**

Document No.	Date	Country	Translation (Yes or No)		
_____	AE	2002-324591	11/08/02	Japan	Cited in the International Search Report
_____	AF				
_____	AG				
_____	AH				
_____	AI				

**OTHER DOCUMENTS**

_____	AJ			
_____	AK			
<table style="width: 100%;"> <tr> <td style="width: 40%;">Examiner</td> <td style="width: 60%;">Date Considered</td> </tr> </table>			Examiner	Date Considered
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